



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/512,968
Filing Date February 24, 2000
Inventor David R. Hembree
Assignee Micron Technology, Inc.
Group Art Unit 2832
Examiner V. Nguyen
Attorney's Docket No. MI22-1363
Title: "Wafer Processing Apparatuses and Electronic Device Workpiece Processing
Apparatuses (As Amended)"

#1510
filed
10-10-01

PRELIMINARY AMENDMENT

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To: Box RCE
Assistant Commissioner for Patents
Washington, D.C. 20231

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
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Sir:

Responsive to the Office Action dated June 26, 2001, Applicant amends and
remarks as follows:

AMENDMENTS

In the Specification

At page 1 before the "Technical Field" section please insert:

--RELATED PATENT DATA

7
This patent resulted from a divisional of and claims priority to U.S. Patent
Application Serial No 09/137,629, filed on August 21, 1998, now U.S. Patent No.